

# **EE 232 Lightwave Devices Lecture 23: Optical Modulators**

Instructor: Ming C. Wu

University of California, Berkeley Electrical Engineering and Computer Sciences Dept.

EE232 Lecture 23-1 Prof. Ming Wu



## Physical Mechanisms for Optical Modulators

- Electro-optic modulators
  - Nonlinear crystals
  - LiNbO<sub>3</sub>, GaAs, InP
- Franz-Keldysh effect
  - Sub-bandgap absorption induced by electric field
  - GaAs, InP
- Quantum confined Stark Effect (QCSE)
  - Absorption modulators in quantum wells
  - Mostly III-V, but also SiGe QWs

- Free carriers effect
  - Refractive index change due to electrons/holes
  - All semiconductors, including Si
- · Thermo-optic effect
  - Refractive index change due to temperature
  - All semiconductors, including Si

EE232 Lecture 23-2

Prof. Ming Wu

1



### **Electro-Optic Effect (Pockels Effect)**

$$\frac{x^2}{n_o^2} + \frac{y^2}{n_o^2} + \frac{z^2}{n_o^2} + 2r_{41}F_xyz + 2r_{52}F_yzx + 2r_{63}F_zxy = 1$$

Table 12.1 A Few Electrooptic Materials With Their Parameters [1, 4, 6, 9]

Point-Group		Refracti	ve Index	Wavelength	Nonzero Electrooptic		
Symmetry	Material	$n_o$ $n_e$		$\lambda_0(\mu m)$	Coefficients $(10^{-12} \text{ m/V})$		
3 <i>m</i>	LiNbO <sub>3</sub>	2.297	2.208	0.633	$r_{13} = r_{23} = 8.6, r_{33} = 30.8$		
					$r_{42} = r_{51} = 28, r_{22} = 3.4$		
32	0	1.544	1.552	0.500	$r_{12} = r_{61} = -r_{22}$		
32	Quartz (SiO <sub>2</sub> )	1.544	1.553	0.589	$r_{41} = -r_{52} = 0.2$		
$\bar{4}2m$	_	1.5115	1 4600	0.546	$r_{62} = r_{21} = -r_{11} = 0.93$		
72111	KH <sub>2</sub> PO <sub>4</sub> (KDP)	1.5074	1.4698 1.4669	0.546	$r_{41} = r_{52} = 8.77, r_{63} = 10.3$		
$\bar{4}2m$				0.633	$r_{41} = r_{52} = 8, r_{63} = 11$		
42 <i>m</i>	NH <sub>4</sub> H <sub>2</sub> PO <sub>4</sub>	1.5266	1.4808	0.546	$r_{41} = r_{52} = 23.76, r_{63} = 8.56$		
	(ADP)	1.5220	1.4773	0.633	$r_{41} = r_{52} = 23.41, r_{63} = 7.828$		
$\overline{42}m$	KD <sub>2</sub> PO <sub>4</sub> (KD*P)	1.5079	1.4683	0.546	$r_{41} = r_{52} = 8.8, r_{63} = 26.8$		
$\bar{4}3m$	GaAs	3.60	$= n_o$	0.9	$r_{41} = r_{52} = r_{63} = 1.1$		
		3.42	$= n_o$	1.0	$r_{41} = r_{52} = r_{63} = 1.5$		
		3.34	$= n_o$	10.6	$r_{41} = r_{52} = r_{63} = 1.6$		
$\bar{4}3m$	InP	3.29	$= n_o$	1.06	$r_{41} = r_{52} = r_{63} = 1.45$		
		3.20	$= n_o$	1.35	$r_{41} = r_{52} = r_{63} = 1.45$ $r_{41} = r_{52} = r_{63} = 1.3$		
$\bar{4}3m$	ZnSe	2.60	$= n_o$	0.633	$r_{41} = r_{52} = r_{63} = 1.5$ $r_{41} = r_{52} = r_{63} = 2.0$		
43m	β-ZnS	2.36					
43m	β-ZnS	2.36	$= n_o$	0.6	$r_{41} = r_{52} = r_{63} = 2.1$		

EE232 Lectur

Prof. Ming Wu



#### **GaAs Electro-Optic Modulators**

Apply electric field in z direction:

$$\frac{x^2}{n_o^2} + \frac{y^2}{n_o^2} + \frac{z^2}{n_e^2} + 2r_{63}F_z xy = 1$$

$$n_{x'} = n_o + \frac{1}{2} n_o^3 r_{63} F_{55}$$

$$n_{y'} = n_o - \frac{1}{2} n_o^3 r_{63} F_{63}$$

For GaAs at  $1\mu$ m wavelength

$$n_o = 3.42$$
,  $r_{41} = r_{52} = r_{63} = 1.5 \times 10^{-12}$  m/V

For applied field of 10<sup>7</sup> V/m

$$\Delta n = \frac{1}{2} n_o^3 r_{63} F_z \approx 3 \times 10^{-4}$$

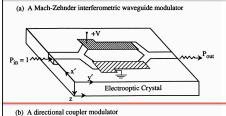
Note: Si is central symmetric and has no electro-optic effect

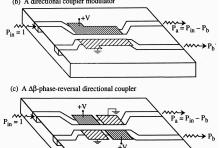
EE232 Lecture 23-4

Prof. Ming Wu



# Converting Index Change to Amplitude Change





$$\begin{split} I_o &= \left| E \right|^2 = \left| \frac{1}{2} E \cdot e^{j\frac{2\pi}{\lambda} (n_o + \Delta n)L} + \frac{1}{2} E \cdot e^{j\frac{2\pi}{\lambda} (n_o - \Delta n)L} \right|^2 \\ &= \left| E \right|^2 \frac{1}{2} \left( 1 + \cos \left( \frac{4\pi \Delta nL}{\lambda} \right) \right) \\ &= \left| E \right|^2 \frac{1}{2} \left( 1 + \cos \left( \frac{4\pi n_o^3 r_{63} F_z L}{\lambda} \right) \right) \end{split}$$

$$F_z = \frac{V}{d}$$

 $V_{\pi}$ : voltage at  $\pi$  phase shift

$$V_{\pi}L = \frac{d\lambda}{4n_o^3 r_{63}}$$

GaAs at  $1\mu m$ , and assume d of  $1\mu m$ 

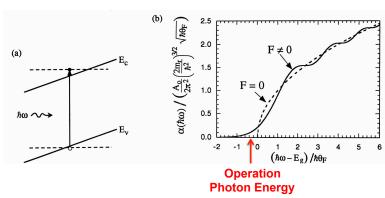
$$V_{\tau}L \approx 4 \text{ [V \cdot mm]} \implies \text{Long devices}$$

Prof. Ming Wu



EE232 Lecture 23-5

#### Absorption Modulator with Franz-Keldysh Effect



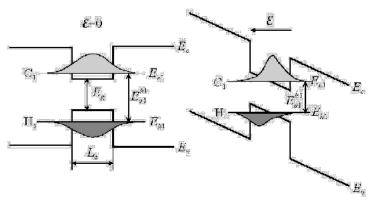
- Absorption edge shifts to lower energy with electric field in direct bandgap semiconductor (e.g., GaAs, InP)
- · Absorption up to 1000 cm<sup>-1</sup>
  - Short devices ~ 100µm

EE232 Lecture 23-6

Prof. Ming Wu

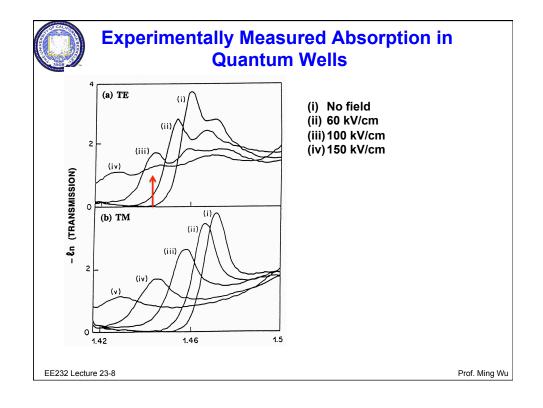


### **Quantum Confined Stark Effect (QCSE)**



- Absorption edge shifts to lower energy with electric field in quantum wells
- Absorption up to 1000 cm<sup>-1</sup>
  - Short devices ~ 100µm

EE232 Lecture 23-7 Prof. Ming Wu





### **Thermo-Optic Effect in Si**

Experimentally measured data at  $1.55\mu m$ :

$$\frac{dn}{dT} = 9.48 \times 10^{-5} + 3.47 \times 10^{-7} T - 1.49 \times 10^{-10} T^2$$

At 300K, 
$$\frac{dn}{dT} \approx 1.86 \times 10^{-4} \text{ K}^{-1}$$

With  $\Delta T$  of 270K,  $\Delta n \approx 0.05$ 

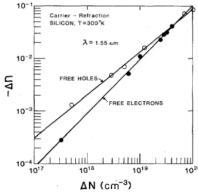
Corresponding length for  $\pi$  phase shift is 15.5 $\mu$ m

- Index change due to (1) thermal expansion, (2) bandgap energy reduction with temperature
- · Relatively strong compared with carrier effect
- · Low optical loss introduced by heating
- Usually slow, limited by thermal RC time. Modulation time is on the order of milliseconds. For small structures, it could approach microsecond response time.
- · Too slow for modulators, but often used in tunable filters, switches.
- · High power consumption

EE232 Lecture 23-9 Prof. Ming Wu



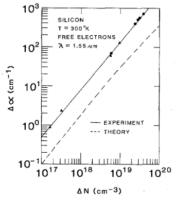
#### Free-Carrier Effect in Si



At  $1.55\mu m$ ,

$$\Delta n = -8.8 \times 10^{-22} \Delta N_e - 8.8 \times 10^{-18} \left(\Delta N_h\right)^{0.8}$$

$$\Delta \alpha = 8.5 \times 10^{-18} \Delta N_e + 6.0 \times 10^{-18} \Delta N_h$$



For  $\Delta N_e = \Delta N_h = 10^{18} \text{ cm}^{-3}$ 

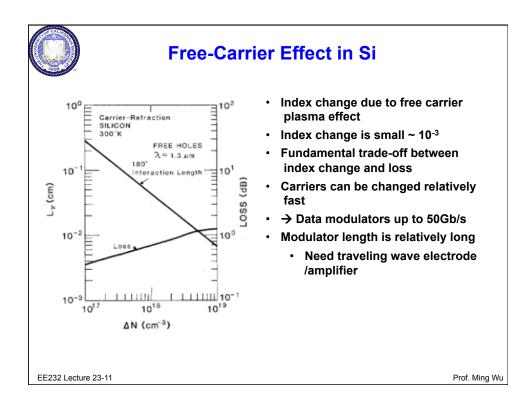
$$\Delta n \approx -0.003$$

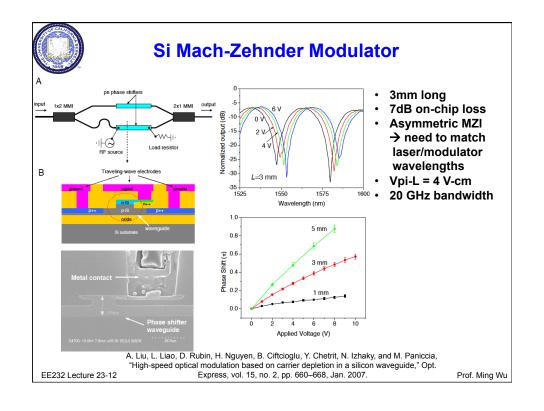
 $\Delta \alpha \approx 14.5 \text{ cm}^{-1}$ 

R. A. Soref and B. R. Bennett, "Electrooptical effects in silicon," IEEE Journal of Quantum Electronics, vol. 23, no. 1, pp. 123–129, Jan. 1987.

EE232 Lecture 23-10

Prof. Ming Wu







#### Si Mach-Zehnder Modulators

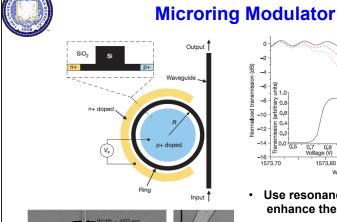
Table 1. , Performance comparison of previously reported high-speed silicon MZMs (>25  $\,$  Gb/s) and devices in this work.

Reference	[17]	[15]	[25]	[27]	[24]	[26] <sup>&amp;</sup>	L = 2 mm	L = 4 mm	L=6 mm
Device length (mm) <sup>%</sup>	1	0.12	1.35	1	3.5	2.4	2	4	6
V <sub>π</sub> ·L (V·cm)	4	0.5	11	2.8	2.7	2.4	2.4	2.08	1.86
V <sub>π</sub> (V) *	NA	NA	NA	NA	~8	10	12	5.2	3.1
Insertion loss (dB)#	4	2.5	15	3.7	15	4.3	4.1	6.6	9.0
Speed (Gb/s)	40	25	40	50	40	30	~50	~40	30

Device length: the phase shifter length rather than the whole device length.

P. Dong, L. Chen, and Y. Chen, "High-speed low-voltage single-drive push-pull silicon Mach-Zehnder modulators," Optics Express, vol. 20, no. 6, p. 6163, Mar. 2012.

EE232 Lecture 23-13 Prof. Ming Wu



- Probe wavelength

  Probe wavelength

  Probe wavelength

  O.58 V, < 0.1 µA

  O.58 V, < 0.1 µA

  O.58 V, < 0.1 µA

  O.57 V, 11.1 µA

  O.94 V, 19.9 µA

  Wavelength (nm)
  - Use resonance in microring to enhance the modulation
  - Reduce modulator size from millimeters to tens of microns
  - Enhanced modulation efficiency
- · Reduced bandwidth
- Must match laser/resonator wavelengths

Q. Xu, B. Schmidt, S. Pradhan, and M. Lipson, "Micrometre-scale silicon electro-optic modulator," Nature, vol. 435, no. 7040, pp. 325–327, May 2005. Prof. Ming Wu

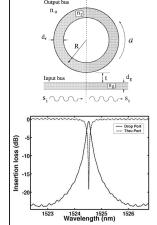
7

<sup>\*</sup>  $V_{\pi}$  under dc. NA represents that the phase shifter is too short and a  $\pi$ -phase shift may not be achievable before breakdown voltage.

Insertion loss is defined as the on-chip loss for the wavelength at maximum transmission of the MZMs.

<sup>\*</sup>Devices in [26] and in this work are single-drive push-pull MZMs, while the rest are not.





$$\begin{aligned} s_t &= \frac{j(\omega - \omega_0) + \frac{1}{\tau} - \frac{2}{\tau_e}}{j(\omega - \omega_0) + \frac{1}{\tau}} \\ \left| s_t \right|^2 &= \frac{(\omega - \omega_0)^2 + \left(\frac{1}{\tau} - \frac{2}{\tau_e}\right)^2}{(\omega - \omega_0)^2 + \left(\frac{1}{\tau}\right)^2} \\ \left| s_d \right|^2 &= \left| s_i \right|^2 - \left| s_t \right|^2 = \frac{\frac{4}{\tau_e^2}}{(\omega - \omega_0)^2 + \left(\frac{1}{\tau}\right)^2} \\ \frac{1}{\tau} &= \frac{1}{\tau_t} + \frac{1}{\tau_e} + \frac{1}{\tau_d} \end{aligned}$$

$$\frac{1}{\tau_{l}}$$
: intrinsic loss 
$$\frac{1}{\tau_{e}}$$
: coupling to transmission 
$$\frac{1}{\tau_{e}}$$
: coupling to output (drop) Critical Coupling: 
$$\frac{1}{\tau_{e}} = \frac{1}{\tau_{l}} + \frac{1}{\tau_{d}}$$

B. E. Little, S. T. Chu, H. A. Haus, J. Foresi, and J.-P. Laine, "Microring resonator channel dropping filters," Journal of Lightwave Technology, vol. 15, no. 6, pp. 998–1005, Jun. 1997.

EE232 Lecture 23-15 Prof. Ming Wu

